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Tech ID: 21586



ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- ▶ Approaching Schottky-Mott Limit in Van Der Waals Metal Semiconductor Contacts
- ▶ Chemical Vapor Deposition Growth of the Large Single Crystalline Domains of Monolayer and Bilayer
- ▶ Double-Negative-Index Ceramic Aerogels For Thermal Superinsulation
- ▶ Single-Atom Tailoring of Platinum Nanocatalysts for High-Performance Multifunctional Electrocatalysis
- ▶ Palladium Alloy Hydride Nano Materials
- ▶ High Performance Thin Films from Solution Processible Two-Dimensional Nanoplates

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